

12010317

Basic Patent (No,Kind,Date): EP 622858 A2 19941102 <No. of Patents: 038>
GALLIUM NITRIDE-BASED III-V GROUP COMPOUND SEMICONDUCTOR DEVICE AND
METHOD OF PRODUCING THE SAME. (English; French; German)

Patent Assignee: NICHIA KAGAKU KOGYO KK (JP)
Author (Inventor): NAKAMURA SHUJI C O NICHIA CHEM (JP); YAMADA TAKAO C O
NICHIA CHEM I (JP); SENOH MASAYUKI C O NICHIA CHEM (JP); BANDO KANJI C
O NICHIA CHEM IN (JP); YAMADA MOTOKAZU C O NICHIA CHE (JP)

Designated States : (National) DE; FR; GB; IT; NL

IPC: *H01L-033/00; H01L-031/0224; H01L-021/28

CA Abstract No: *122(06)069833D; 122(06)069833D

Derwent WPI Acc No: *C 94-334913; C 99-582973; C 94-334913

Language of Document: English

Patent Family:

Patent No	Kind	Date	AppliC No	Kind	Date
CN 1102507	A	19950510	CN 94106935	A	19940428
CN 1213863	A	19990414	CN 98118311	A	19980811
CN 1046375	B	19991110	CN 94106935	A	19940428
DE 69425186	CO	20000817	DE 69425186	A	19940427
DE 69425186	T2	20010322	DE 69425186	A	19940427
EP 952617	A1	19991027	EP 99114356	A	19940427
EP 622858	A2	19941102	EP 94106587	A	19940427
EP 622858	A3	19950517	EP 94106587	A	19940427
EP 622858	B1	20000712	EP 94106587	A	19940427
JP-6314822	A2	<u>19941108</u>	JP 93124890	A	19930428
JP 6338632	A2	19941206	JP 93129313	A	19930531
JP 7045867	A2	19950214	JP 93207274	A	19930728
JP 7094782	A2	19950407	JP 93234684	A	19930921
JP 7094783	A2	19950407	JP 93234685	A	19930921
JP 7106633	A2	19950421	JP 93253171	A	19931008
JP 7221103	A2	19950818	JP 948727	A	19940128
JP 7254733	A2	19951003	JP 94302586	A	19941207
JP 2001203389	A2	20010727	JP 2000381850	A	20001215
JP 2697572	B2	19980114	JP 93234684	A	19930921
JP 2748818	B2	19980513	JP 93129313	A	19930531
JP 2770717	B2	19980702	JP 93234685	A	19930921
JP 2770720	B2	19980702	JP 93253171	A	19931008
JP 2783349	B2	19980806	JP 93207274	A	19930728
JP 2803742	B2	19980924	JP 93124890	A	19930428
JP 3154364	B2	20010409	JP 948727	A	19940128
JP 3180871	B2	20010625	JP 94302586	A	19941207
KR 225612	B1	19991015	KR 9822092	A	19980612
US 5563422	A	19961008	US 234001	A	19940428
US 5652434	A	19970729	US 665759	A	19960617
US 5767581	A	19980616	US 670242	A	19960617
US 5877558	A	19990302	US 995167	A	19971219
US 6093965	A	20000725	US 209826	A	19981211
US 20010022367	AA	20010920	US 750912	A	20010102
US 20030094620	AA	20030522	US 292583	A	20021113
US 6204512	BA	20010320	US 448479	A	19991124
US 6507041	BB	20030114	US 750912	A	20010102
TW 403945	B	20000901	TW 83103775	A	19940427
TW 491406	Y	20020611	TW 90209918	U	19940427

Priority Data (No,Kind,Date):

JP 93124890 A 19930428
JP 948727 A 19940128
JP 948726 A 19940128
JP 93129313 A 19930531
JP 93207274 A 19930728
JP 93234684 A 19930921
JP 93234685 A 19930921

JP 93253171 A 19931008
EP 94106587 A3 19940427
JP 94302586 A 19941207
JP 2000381850 A 20001215
KR 949055 A3 19940417
US 665759 A 19960617
US 234001 A3 19940428
US 670242 A 19960617
US 995167 A 19971219
US 670242 A3 19960617
US 209826 A 19981211
US 995167 A3 19971219
US 750912 A 20010102
US 448479 A3 19991124
US 209826 A3 19981211
US 292583 A 20021113
US 750912 A3 20010102
US 448

<< BACK

[Search Jobs](#)[My Monster](#)[Career Center](#)[SEARCH JOBS](#)

US-CA-Fremont-Director of Patent Prosecution ..

Status: Full Time, Employee**Job Location:** Fremont

Location: Fremont

Job Summary: Manage prosecution of Lexar patents

Primary Responsibilities:

- Draft, file and generally prosecute new patents
- Manage patent portfolio
- Identify new inventions

Qualifications:

- Electrical Engineering background in semiconductors preferred

Education: J.D.

Supervisory Responsibilities: Paralegal

Lexar is an equal opportunity employer

Contact Information ..hr@lexarmedia.com

Lexar Media

[EMAIL THIS JOB TO A FRIEND](#)[APPLY NOW](#)

□□<!C-□□function dcsExtend(N,V)□□{□□□dcsI